INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 30, 2024

IGI Report Number	LG649405805
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	8.29 X 5.72 X 3.85 MM

GRADING RESULTS

Carat Weight	1.60 CARAT
Color Grade	I
Clarity Grade	VS 1

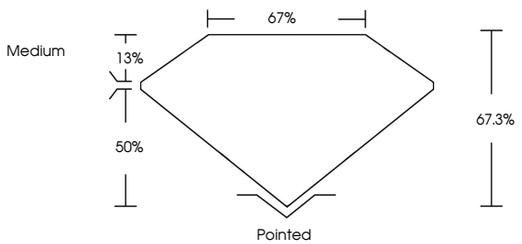
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG649405805

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG649405805
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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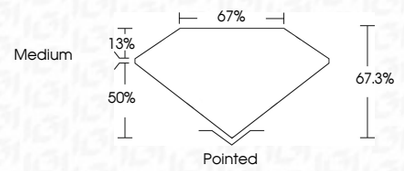
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IGI

August 30, 2024
IGI Report No LG649405805
CUT CORNERED RECT. MODIFIED BRILLIANT
8.29 X 5.72 X 3.85 MM
Carat Weight 1.60 CARAT
Color Grade I
Clarity Grade VS 1
Depth 67.3%
Table 67%
Girdle Medium
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG649405805
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa